



Docket No. 740819-725

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: )  
Yasutoshi OKUNO et al. ) Group Art Unit: 2823  
Application No. 10/032,564 ) Examiner: Michelle Estrada  
Filed: January 2, 2002 ) Confirmation No. 5824  
For: METHOD FOR FABRICATING ) Date: October 3, 2003  
SEMICONDUCTOR DEVICE

CERTIFICATE OF MAILING OR TRANSMISSION  
[37 CFR 1.8(a)]

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Signature: Deborah Movahhedi  
Name: Deborah Movahhedi

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed April 3, 2003, please consider the amendments and remarks in connection with the above-identified application as follows.

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